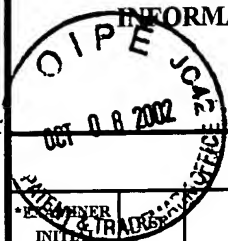


<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)	Docket Number (Optional) <b>35706.5405</b>	Application Number <b>10/055,679</b>
	Applicant(s) <b>Kannan Raj et al.</b>	
	Filing Date <b>January 22, 2002</b>	Group Art Unit <b>2812</b>



### U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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### FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>JP</i>	JP 62 132385	06/15/87	Japan			✓	
<i>JP</i>	JP 57 195209	11/30/82	Japan			✓	
<i>FR</i>	FR 2 569 015	02/14/86	France				✓

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Bestwick T, "A Silicon-Based Integrated Optical Manufacturing Technology," May 25, 1998, pgs. 566-571
	Tran D. et al. "Monolithic Integrated Optical Micro-Bench for High Density Photonics Packaging," May 25, 1998, pgs. 588-591

EXAMINER <i>Rougha Wittle</i>	DATE CONSIDERED <i>26 Nov 02</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.